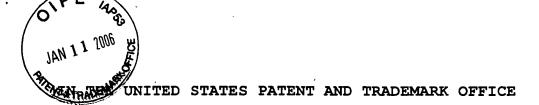
RCEMU

AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Kuniyuki KAJITA						Docket No. L9289.01227	
Application No.	Filing Date December 21, 2001	Examiner M. Chaudry	- Mar	Customer N 24257	0.	Group Art Unit 2133	Confirmation No. 2181
Divention: 12 PARATUS AND METHOD FOR CODING/DECODING							
COMMISSIONER FOR PATENTS: Transmitted herewith is an amendment in the above-identified application.							
The fee has been calculated and is transmitted as shown below.							
		CLAIMS AS AM	ENDEC)	_		
	CLAIMS REMAINING	HIGHEST #	NUMB	ER EXTRA	_	RATE	ADDITIONAL
	AFTER AMENDMENT	PREV. PAID FOR	CLAIMS	PRESENT			FEE
TOTAL CLAIMS	18 -	20 =	<u> </u>		X	\$50.00	\$0.00
INDEP. CLAIMS	6 -	6 =	<u></u>	0	X	\$200.00	\$0.00
Multiple Dependen	nt Claims (check if appl	licable)					\$0.00 \$0.00
No additional fee is required for amendment. Please charge Deposit Account No. in the amount of A check in the amount of to cover the filing fee is enclosed. The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 19-4375 Any additional filing fees required under 37 C.F.R. 1.16. Any patent application processing fees under 37 CFR 1.17. Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038. Dated: January 11, 2006 I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on (Date)							
cc:		Signature of Person Mailing Correspondence Typed or Printed Name of Person Mailing Correspondence					



In re the Application

Inventor:

Kuniyuki KAJITA

Art Unit: 2133

Appln. No.: 10/018,658

Exr. M. Chaudry

Filed:

December 21, 2001

For:

APPARATUS AND METHOD FOR CODING/DECODING

SUMMARY OF SUBSTANCE OF INTERVIEW AND AMENDMENT SUBMISSION FOR REQUEST FOR CONTINUED EXAMINATION

Assistant Commissioner of Patents Washington, DC 20231

Dear Sir:

Please amend this application as follows: